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TC 1700

PATENT

SAM435-100/00656

Customer No.24,118

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: DONG-IL CHO)
SERIAL NO.: 09/614,785)
FILED: JULY 12, 2000)
FOR: SILICON ETCHING)
APPARATUS USING XeF₂)
GROUP ART UNIT: 1763)
EXAMINER: PARVIZ HASSANZADEH)

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AMENDMENT

Assistant Director of Patents
Box Non-Fee Amendment
Washington, D.C. 20231

Dear Sir:

Please reexamine the above-identified application in view of the following amendments and remarks.

IN THE CLAIMS:

Please amend Claims 8 and 12 as follows:

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Assistant Director of Patents, Washington, D.C. 20231, on February 26, 2003

Sanjiv Kumar